



2875/4

03500.015730.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKASHI IWAKI ET AL.)
Appln. No.: 09/941,782)
Filed: August 30, 2001)
For: ELECTRON-EMITTING)
DEVICE, ELECTRON SOURCE)
AND METHOD FOR)
MANUFACTURING IMAGE-)
FORMING APPARATUS)

Examiner: P. Macchiarolo
Group Art Unit: 2875
July 10, 2003

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
10/370,662	2/24/03	1762

A copy of the cited application is enclosed.

07/21/2003 WABRHAM1 00000048 09941782

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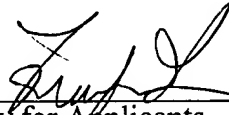
CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2).

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
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Registration No. 42,476

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NY_MAIN 359942v1

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 03500.015730		APPLICATION NO. 09/941,782	
				APPLICANT TAKASHI IWAKI ET AL.			
				FILING DATE AUGUST 30, 2001		GROUP 2875	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0117670	8/2002	Horiguchi et al.	257	59	

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	EP	1 184 886 A1	3/2002	EPO	H01J	9/02	
	JP	11-120901	4/1999	Japan	H01J	9/02	Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Akiyoshi Baba et al., "Field Emission from an Ion-Beam-Modified Polyimide Film," Japanese Journal of Applied Physics, Publication Board Japanese Journal of Applied Physics, Tokyo, JP, Vol. 38 (1999), NR. 3A pp. L261-L263.

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1